

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76587

Kouji TAKAHASHI, et al.

Appln. No.: 10/619,181

Group Art Unit: 1791

Confirmation No.: 4972

Examiner: Jason L LAZORCIK

Filed: July 15, 2003

For: GLASS SUBSTRATE FOR A MASK BLANK, METHOD OF PRODUCING A GLASS  
SUBSTRATE FOR A MASK BLANK, MASK BLANK, METHOD OF PRODUCING  
THE MASK BLANK, TRANSFER MASK, AND METHOD OF PRODUCING A  
TRANSFER MASK

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month(s), extending the time for responding to the Office Action of February 13, 2008 to June 13, 2008.

The statutory fee of \$120.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

*/Alan J. Kasper/*

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Date: June 11, 2008